Swiss Photonics Workshop on SLM



Grating Light Valve Technology & Applications

Ecole Polytechnique Fédérale de Lausanne October 2017

SILICON LIGHT MACHINES



Outline



- GLV Technology
- Direct Write Applications
- Emerging Applications
- Technology Roadmap
- Conclusions

Grating Light Valve (GLV[™])







The GLV is a high-speed diffractive MEMS light modulator fabricated from aluminum & silicon-nitride

Light Modulation with GLV





The GLV uses phase interference to modulate light intensity reflected into fixed diffraction angles at high speeds

Intensity-Voltage Curves



Dynamic Response



GLV Illumination & Imaging





GLV-Based Laser Displays





62.1

E&S EVANS & SUTHERLAND

Sony Laser Dream Theater (10x50m)

The original application of the GLV was in laserbased displays



E&S Digistar Planetarium Projector

SCREEN & Silicon Light Machines



SCREEN

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Precision Equipment Supplier

- Founded 1943 (roots in Kyoto from 1868)
- >5000 employees, >\$2.5B annual revenue
- Semiconductor fabrication equipment
- Printed circuit board tools
- Flat panel display tools
- Graphic arts systems

Optical MEMS Specialists

- Unique diffractive MEMS technology
- Building optical MEMS for >20 years
- Semiconductor, electronics & optics
- Demanding industrial applications
- Began working with SCREEN 1997
- SCREEN subsidiary since 2008

SLM-SCREEN Collaboration



1997	2000	2003	2006	2009	2012	2015	2018
					/ / /		
Begin joint develo pment	Gen 1 GLV 1080-ch 8-bit AMP 40W IR	Gen 2 GLV 1080-ch 10-bit AMP 8-bit PWM 80W IR	Gen3 GLV 1080-ch 10-bit AMP 8-bit PWM 100W IR Hi Efficiency	Gen 1 iGLV 8192-ch 10-bit AMP 8-bit PWM (a 4W UV	analog) 8	Gen 2 iGLV 3192-ch 10-bit AMP 3-bit PWM (digital) 3W UV	



Silicon Light Machines has been building spatial light modulators to enable SCREEN's highest-performance digital print systems for nearly 20 years.

Computer-to-Plate (CtP)









Images courtesy of SCREEN Graphic and Precision

1088 Channel GLVs used in SCREEN CtP digital systems

- High resolution: 2400 dpi (10um features)
- High throughput: >70 meter-scale flexible aluminum substrates per hour
- High-power: 80-100W infrared per GLV (power densities up to 10kW/cm²)

SCREEN has global #1 market share of CtP plate-setters

- OEM for AGFA & Fuji and others
- Thousands of GLV-based systems in use today around the globe

Computer-to-Plate at 2400 dpi

Offset Printing Plate (AI)





- Precise amplitude & PWM control of GLV = high-resolution halftone images
 - Large format (1m)
 - Short print time (30s)



High Resolution Mask Writing





Images courtesy of Heidelberg Instruments GmbH

Heidelberg VPG mask writer based on GLV technology

- 500 nm minimum feature
- 10 nm addressable grid
- Semiconductor, TFT, PCB
- 1088 Ch. GLV x 10-bit



Signal A = InLens

Mag = 15.00 K X

Stage at Y = 86 849 mn

D4 500 nm

EHT = 2.00 kV

WD = 4.2 mm

Heidelberg Instruments Mask Writer





- High resolution & accuracy
 - Semiconductor photo masks
- Optimization for Mura
 - TFT and imager photo masks
- Variety of mask size and substrate thicknesses
 - Packaging photo masks
 - PCB photo masks





The GLV's high speed enables pulse-width modulation (PWM)

- Allows optical transition to be placed anywhere within one column period
- Column strobe & delay clock are control signals derived from stage
- Useful in direct-write systems with <u>continuous</u> media motion
 - Enables higher spatial resolution (effectively more pixels)
 - Maintains high throughput (i.e. single pass, not multiple exposures)

Pulse-Width Modulation (PWM)



- Dynamic PWM of G8192 device
- 355nm pulse edges can be programmed over 4us column
 - Delay resolution is 20ns



Ultra-Violet Direct Imaging





SCREEN 355nm direct imaging tool advanced packaging

- 2um minimum features on 0.5um placement grid
- 65 wafers per hour @ 100mJ/cm² hour

• Kyoto city map shown printed onto wafer using DW3000

Individual houses are resolved on this map.

Aluminum Laser Marking





Wavelength	532 nm			
Pulse width	6 ps			
Repetition rate	500 kHz			
Demag	20 x			

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GLV used for AI laser marking

- Pico-second 532nm pulsed laser
- Modification of sub-surface Al microstructure beneath oxide
- Throughput improvement over single beam galvo-scanner



3D Printing

GLV used in polymer selective laser sintering (SLS)

- Faster write times than single-beam galvo scan
- Improved sinter quality with line beam
- Analog gray scale enables variable power sinter





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Super-Continuum Spectral Shaping







- GLV has been used to spectrally shape output of super-continuum laser
- Solar simulator for characterization of multi-junction solar cells
 - Improved flexibility & precision over lamps & LEDs
 - National Institute of Standards and Technology



- More patterns = improved surface knowledge
- Amenable to in-line (continuous) inspection



SLM 1088-HS Module

Structured Illumination / 3D Imaging



Light Sheet Microscopy







R. Itoh, J. Landry, S. Hamann, O. Solgaard

Phase GLV used for structured illumination for background suppression & shadow mitigation in biological fluorescence images

Light Detection and Ranging (LIDAR)

Angular Modulation with Phased-Array Grating



GLV can be used for beam steering (and detection) in LIDAR

- Advantages are very high scan speeds
- High sensitivity & angular resolution

Solgaard Group at Stanford studying random-access LIDAR

GLV allows arbitrary phase configurations







SLM Technology Roadmap



Roadmap

1D to 2D

modulators

PLV allows

continued growth in

encompasses

GLV and PLV technologies

Transition from

between 10⁴-10⁵

throughput and

power handling



Pixel Count (pixels)

Planar Light Valve (PLV)







Inherited properties...

- High Speed
- Analog gray-scale
- Non-contact MEMS
- High power handling

New properties...

- Higher pixel counts
- Non-critical illumination
- Increased étendue
- 2D phase modulation

Planar Light Valve is 2D analog 1D GLV

Retains GLV advantages & brings new properties

PLV enables further improvements in throughput & power-handling

More pixels, non-critical illumination

SLM developing 8192-channel PLV module

- 32 x 256 modulator for 405nm
- 8-bit amplitude control x 250kHz refresh rate





PLV Optical Response

15um Pitch PLV

IV Curve



0th order contrast ratio > 50:1, efficiency > 70%

Summary



The Grating Light Valve has unique attributes...

- High-speed (10-1000X faster than other modulators)
- Analog gray-scale (precision dose control, system calibration)
- High-power handling (100W per module in IR)
- Non-contact operation, high reliability

GLV is well-suited to direct-write lithography

- GLV has been used for years in SCREEN's CtP plate-setters
- GLV enabling new UV lithography tools (UVDI & mask writing)

GLV an attractive option for emerging applications

Laser making, 3D printing, machine vision, spectral shaping, etc.

PLV: path to increased throughput & power handling

- Planar Light Valve is the 2D analog of the 1D GLV
- More pixels, non-critical illumination

SLM focused on next-generation light modulators

High throughput devices for SCREEN <u>and</u> for other customers